



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Xiaowei Deng

Docket No: TI-29320

Serial No: 09/932,763

Conf. No: 5414

Examiner: Daniel D. Chang

Art Unit: 2819

Filed: 08/16/2001

For: SILICON-ON-INSULATOR DYNAMIC LOGIC

AMENDMENT PURSUANT TO 37 CFR 1.116

Mail Stop AF
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

MAILING CERTIFICATE UNDER 37 C.F.R. § 1.8(a)

I hereby certify that the above correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on 3-19-04.


Ann Trent

Dear Sir:

Responsive to the Office Action mailed January 26, 2004, in connection with the above identified application, Applicant respectfully submits the following remarks.